

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Andre Luiz Arias, et al.

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For : RADIATION SENSITIVE COATING COMPOSITION USEFUL FOR LITHOGRAPHIC
PRINTING PLATES AND THE LIKE

#511
D.G.
3/21/01
Group Art Unit: To Be Assigned

Examiner: To Be Assigned

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231,

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the International Search Report accompanying the national stage documents being filed on this same date together with a copy of each reference cited therein. The relevance of the references is set forth in the noted English language International Search Report.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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